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Joseph F. Hetz - Reg. No. 41,070

Name of Applicant, Assignee or
Registered Representative

[Signature]
Signature

Our Case No. 10519-57

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Herner et al.)
Serial No.: 09/928,975)
Filed: August 13, 2001)
For: Low Resistivity Titanium Silicide)
on Heavily Doped Semiconductor)

Examiner: T. Magee

Group Art Unit: 2811

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AMENDMENT AND RECORD OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Please enter the following amendment and remarks in response to the Office Action mailed January 6, 2003.

IN THE CLAIMS

Please amend Claim 8 as follows. Appendix A (at Tab A) contains a marked-up version of this claim showing the changes being made.